

Abstracts

FET noise-parameter determination using a novel technique based on S_{11} noise-figure measurements

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A novel method for measuring the four noise parameters of a field-effect transistor (FET) is presented. It is based on the determination of its intrinsic noise matrix elements [C_{11}^{INT} , C_{22}^{INT} , $\text{Re}(C_{12}^{INT})$, $\text{Im}(C_{12}^{INT})$] by fitting the measured device noise figure for a matched source reflection coefficient (Γ_{S0}) at a number of frequency points, thus, a tuner is not required. In contrast to previous works, no restrictive assumptions are made on the intrinsic noise sources. The receiver full-noise calibration is easily performed by using a set of coaxial and on-wafer standards that are commonly available in a microwave laboratory, thus, an expensive broad-band tuner is not required for calibration either. On-wafer experimental verification up to 26 GHz is presented and a comparison with other Γ_{S0} -based and tuner-based methods is given. As an application, the dependence of the FET intrinsic noise sources as a function of the bias drain-current and gate-length is obtained.

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